



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Osama Khouri et al.
Application No. : 10/756,195
Filed : January 13, 2004
For : SUBLITHOGRAPHIC CONTACT STRUCTURE, IN
PARTICULAR FOR A PHASE CHANGE MEMORY CELL, AND
FABRICATION PROCESS THEREOF

Examiner : Thanhha S. Pham
Art Unit : 2813
Docket No. : 854163.412
Date : March 2, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

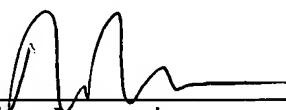
Commissioner for Patents:

In accordance with 37 CFR 1.56 and 1.97 through 1.98, applicants wish to make known to the U.S. Patent and Trademark Office the references set forth on the attached Information Disclosure Statement. Copies of cited U.S. patents and published patent applications are not required and accordingly have not been provided. Copies of any other cited references are enclosed. As to any reference cited, applicants do not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserve the right to traverse or antedate any such reference, as by a showing under 37 CFR 1.131 or other method. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

A fee of \$180 is submitted in accordance with 37 CFR 1.97(c). The Director is authorized to charge any other fees which may be required, or credit any overpayment to Deposit Account No. 19-1090.

Respectfully submitted,
Seed Intellectual Property Law Group PLLC



Robert Iannucci
Registration No. 33,514

RXI:lm
Enclosures:
Postcard
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Information Disclosure Statement
Cited References (2)

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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.

854163.412

APPLICATION NO.

10/756,195

APPLICANTS

Osama Khouri et al.

FILING DATE

January 13, 2004

GROUP ART UNIT

2813

INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,789,277	08/04/98	Zahorik et al.	438	95	
	AB	5,814,527	09/29/98	Wolstenholme et al.	438	5	
	AC	5,952,671	09/14/99	Reinberg et al.	257	3	
	AD	5,970,336	10/19/99	Wolstenholme et al.	438	238	
	AE	6,031,287	02/29/00	Harshfield	257	734	
	AF	6,238,946	05/29/01	Ziegler	438	50	
	AG	6,512,241	01/28/03	Lai	257	4	
	AH	6,541,333	04/01/03	Shukuri et al.	438	243	
	AI	6,613,604	09/02/03	Maimon et al.	438	95	
	AJ	6,617,192	09/09/03	Lowrey et al.	438	95	
	AK	6,750,079	06/15/04	Lowrey et al.	438	95	
	AL	2002/0017701	02/14/02	Klersy et al.	257	536	
	AM	2003/0075778	04/24/03	Klersy	257	536	
	AN	2003/0219924	11/27/03	Bez et al.	438	102	
	AO	2003/0231530	12/18/03	Bez et al.	365	200	
	AP	2004/0012009	01/22/04	Casagrande et al.	257	4	
	AQ	2004/0166604	08/26/04	Ha et al.	438	102	
	AR	09/276,273		Klersy			03/25/99

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AS	WO 00/57498	09/28/00	WIPO		

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 854163.412	APPLICATION NO. 10/756,195
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	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AK					
	AL					
	AM					
	AN					
	AO					

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AP	Palun, L., et al., "Fabrication of Single Electron Devices by Hybrid (E-Beam/DUV) Lithography," <i>Microelectronic Engineering</i> 53:167-170, 2000.
AQ	
AR	

EXAMINER	DATE CONSIDERED
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